

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: Not yet assigned
Applicants: Eri TSUKADA, et al.
Filed Internationally: January 19, 2005
US National: Herewith
Title: METHOD FOR PRODUCING SILICON NITRIDE FILMS AND
SILICON OXYNITRIDE FILMS BY CHEMICAL VAPOR
DEPOSITION
TC/A.U.: Unknown
Examiner: Unknown
Docket No.: Serie 6497
Customer No.: 000040582

INFORMATION DISCLOSURE STATEMENT

Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. § 1.56, Applicants hereby submit the following information in conformance with 37 C.F.R. §§ 1.97 and 1.98. Pursuant to 37 C.F.R. § 1.98, a copy of each of the non-US patent documents cited on the attached PTO Form 1449 is enclosed.

No fee is due at this time in accordance with 37 C.F.R. § 1.97. However, the Commissioner is hereby authorized to charge any appropriate fees under 37 C.F.R. §§ 1.16, 1.17 and 1.21 that may be required by this paper, and to credit any overpayment, to Deposit Account No. 01-1375.

To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that an Examiner-initialed copy of this form be returned to the undersigned. This paper is submitted in duplicate.

Respectfully submitted,



Linda K. Russell, Reg. No. 34,918

Date: July 26, 2006

Air Liquide
Intellectual Property Department
2700 Post Oak Boulevard, Suite 1800
Houston, Texas 77056
(713) 624-8956 Phone – (713) 624-8950 Fax

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: Not yet assigned
Applicants: Eri TSUKADA, et al.
Filed Internationally: January 19, 2005
US National: Herewith
Title: METHOD FOR PRODUCING SILICON NITRIDE FILMS AND
SILICON OXYNITRIDE FILMS BY CHEMICAL VAPOR
DEPOSITION
TC/A.U.: Unknown
Examiner: Unknown
Docket No.: Serie 6497
Customer No.: 000040582

INFORMATION DISCLOSURE STATEMENT

Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. § 1.56, Applicants hereby submit the following information in conformance with 37 C.F.R. §§ 1.97 and 1.98. Pursuant to 37 C.F.R. § 1.98, a copy of each of the non-US patent documents cited on the attached PTO Form 1449 is enclosed.

No fee is due at this time in accordance with 37 C.F.R. § 1.97. However, the Commissioner is hereby authorized to charge any appropriate fees under 37 C.F.R. §§ 1.16, 1.17 and 1.21 that may be required by this paper, and to credit any overpayment, to Deposit Account No. 01-1375.

To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that an Examiner-initialed copy of this form be returned to the undersigned. This paper is submitted in duplicate.

Respectfully submitted,



Linda K. Russell, Reg. No. 34,918

Date: July 26, 2006

Air Liquide
Intellectual Property Department
2700 Post Oak Boulevard, Suite 1800
Houston, Texas 77056
(713) 624-8956 Phone – (713) 624-8950 Fax

10/587427

10/587427
 IAP11 Rec'd PCT/PTO 26 JUL 2006

INFORMATION DISCLOSURE CITATION
 (USE SEVERAL SHEETS IF NECESSARY)

APPL. NO. Serie 6497	SERIAL NO. Not yet assigned
APPLICANT(S) Eri TSUKADA, et al.	
FILING DATE Herewith	GROUP Unknown

U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date	
	A1	US 2002 090835	7/11/2002	Chakravarti et al.				
	A2	US 2004 132257	7/08/2004	Furuhashi et al.				
	A3	US 2005 025885	2/03/2005	McSwiney et al.				

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation		
							Yes	No	
	B1	WO 03 046254	6/05/2003	PCT					
	B2	WO 2004 017383	2/26/2004	PCT					
	B3	WO 2004 059707	7/15/2004	PCT					

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	C1	International Search Report for PCT/IB2005/000170							
	C2	Patent Abstracts of Japan, vol. 1996, no. 01, January 31, 1996 & JP 07 235535, September 54, 1995							
	C3	M. Tanaka et al., Journal of the Electrochemical Society, Volume 147, p. 2284 (2000)							
	C4	R. K. Laxman et al., Proceedings of the VMIC Conference, p. 568 (1998)							

Examiner	Date Considered
----------	-----------------

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.